Electronic Acknowledgement Receipt				
EFS ID:	1430287			
Application Number:	10757274			
International Application Number:				
Confirmation Number:	4324			
Title of Invention:	Xerographic printing system with VCSEL-micro-optic laser printbar			
First Named Inventor/Applicant Name:	Patrick Y. Maeda			
Correspondence Address:	Gunnar G. Leinberg, Esq. Nixon Peabody LLP Clinton Square P.O. Box 31051 Rochester NY 14603-1051 US 5852631014			
Filer:	Jeffrey Noll Townes/Phoebe Jones			
Filer Authorized By:	Jeffrey Noll Townes			
Attorney Docket Number:	D/A1535 (1508/3640)			
Receipt Date:	11-JAN-2007			
Filing Date:	14-JAN-2004			
Time Stamp:	11:00:04			
Application Type:	Utility			
Payment information:	•			

no

File Listing:

Submitted with Payment

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)	
1	Amendment - After Non-Final Rejection	1508-3640_Response_to_Of fice_Action_Mailed_11_Oct_ 06.pdf	37420	no	8	
Warnings:						
Information:						
		Total Files Size (in bytes):	37420			

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.